

A FRAMEWORK FOR ANALYZING THE SCALABILITY OF ION TRAP GEOMETRIES^[1]

- and ion loss.

- performance.



- Heating
- Power consumption

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Geometry	d (µm)	k	$\omega_{\rm rad}/2\pi$ (MHz)	9	V_1
surface	90	0.207	25	0.25	
gnd-surface	46	0.291	25	0.35	
cross-rf	60	0.765	25	0.92	

 $P \propto V_{\rm rf}^2 \Omega_{\rm rf}^2$

[1] the paper for this poster [2] Simon Ragg, Chiara Decaroli, Thomas Lutz, Jonathan P. Home. Segmented ion-trap fabrication using high precision stacked wafers. Rev. Sci. Instrum. 1 October 2019; 90 (10): 103203. <u>https://doi.org/10.1063/1.5119785</u>

